INCH-POUND

MIL-M-38510/758B 15 April 2005 SUPERSEDING MIL-M-38510/758A 27 May 1994

MILITARY SPECIFICATION

MICROCIRCUITS, DIGITAL, ADVANCED CMOS, DECODER/DEMULTIPLEXER, MONOLITHIC SILICON, POSITIVE LOGIC

Reactivated after 15 Apr. 2005 and may be used for new and existing designs and acquisitions

This specification is approved for use by all Departments and Agencies of the Department of Defense.

The requirements for acquiring the product herein shall consist of this specification sheet and MIL-PRF 38535

1. SCOPE

1.1 Scope. This specification covers the detail requirements for monolithic silicon, advanced CMOS, logic microcircuits. Two product assurance classes and a choice of case outlines, lead finishes, and radiation hardness assurance (RHA) are provided and are reflected in the complete Part or Identifying Number (PIN). For this product, the requirements of MIL-M-38510 have been superseded by MIL-PRF-38535 (see 6.3).

1.2 Part or identifying number (PIN). The PIN is in accordance with MIL-PRF-38535 and as specified herein.

1.2.1 <u>Device types.</u> The device types are as follows:

Device type	<u>Circuit</u>
01 02	To be included at a later date 1-of-8 decoder/demultiplexer
03	Dual, 1-of-4 decoder/demultiplexer
04	To be included at a later date

1.2.2 Device class. The device class is the product assurance level as defined in MIL-PRF-38535.

1.2.3 Case outlines. The case outlines are as designated in MIL-STD-1835 and as follows:

Outline letter	Descriptive designator	Terminals	Package style
Е	GDIP1-T16 or CDIP2-T16	16	Dual-in-line
F	GDFP2-F16 or CDFP3-F16	16	Flat pack
Z	GDFP1-G16	16	Flat pack with gull wing
2	CQCC1-N20	20	Square leadless-chip-carrier

Comments, suggestions, or guestions on this document should be addressed to: Commander, Defense Supply Center Columbus, ATTN: DSCC-VAC, P.O. Box 3990, Columbus, OH 43218-3990, or email to CMOS@dscc.dla.mil. Since contact information can change, you may want to verify the currency of this address information using the ASSIST Online database at http://assist.daps.dla.mil.

FSC 5962

1.3 Absolute maximum ratings. 1/2/

	Supply voltage range (V _{CC})	-0.5 V dc to +6.0 V dc
	DC input voltage range (V _{IN})	-0.5 V dc to V _{CC} + 0.5 V dc
	DC output voltage range (V _{OUT})	-0.5 V dc to V_{CC} + 0.5 V dc
	Clamp diode current (I _{IK} , I _{OK})	±20 mA
	DC output current (I _{OUT})	
	DC V _{CC} or GND current (I _{CC} , I _{GND})	±50 mA times the number of outputs
	Storage temperature range (T _{STG})	-65°C to +150°C
	Maximum power dissipation (P _D)	
	Lead temperature (soldering, 10 seconds)	+300°C
	Thermal resistance, junction-to-case (θ_{JC})	
	Junction temperature (T _J)	+175°C
	Case operating temperature range (T _c)	
1.4	Recommended operating conditions. 2/ 3/ 4/	
	Supply voltage range (V _{CC})	+3.0 V dc to +5.5 V dc
	Input voltage range (V _{IN})	
	Output voltage range (V _{OUT})	
	Case operating temperature range (T _c)	
	Maximum low level input voltage(VIL)	0.90 V dc at V _{CC} = 3.0 V dc
		1.35 V dc at V _{CC} = 4.5 V dc
		1.65 V dc at V _{CC} = 5.5 V dc
	Minimum high level input voltage (V _{IH})	
		3.15 V dc at V _{CC} = 4.5 V dc
		3.85 V dc at V _{CC} = 5.5 V dc
	Input rise and fall rate (t _r , t _f) maximum:	• • • •
	V _{CC} = 3.6 V, V _{CC} = 5.5 V	8 ns/V
1.5	Radiation features.	
	Device types 02 and 03:	
	Total dose available (dose rate = 50 – 300 rads (Si)/s)	100 krads (Si)
	Single Event Latch-up (SEL)	
		- 0

<u>1</u>/ Stresses above the absolute maximum rating may cause permanent damage to the device. Extended operation at the maximum levels may degrade performance and affect reliability. The maximum junction temperature may be exceeded for allowable short duration burn-in screening conditions in accordance with MIL-PRF-38535.

^{2/} Unless otherwise noted, all voltages are referenced to GND.

<u>3</u>/ Operation from 2.0 V dc to 3.0 V dc is provided for compatibility with data retention and battery back-up systems. Data retention implies no input transitions and no stored data loss with the following conditions: $V_{IH} \ge 70$ percent of V_{CC} , $V_{IL} \le 30$ percent of V_{CC} , $V_{OH} \ge 70$ percent of V_{CC} at -20μ A, $V_{OL} \le 30$ percent of V_{CC} at 20μ A.

^{4/} Unless otherwise specified, the values listed above shall apply over the full V_{CC} and T_C recommended operating range.

2. APPLICABLE DOCUMENTS

2.1 <u>General</u>. The documents listed in this section are specified in sections 3, 4, or 5 of this specification. This section does not include documents cited in other sections of this specification or recommended for additional information or as examples. While every effort has been made to ensure the completeness of this list, document users are cautioned that they must meet all specified requirements of documents cited in sections 3, 4, or 5 of this specification, whether or not they are listed.

2.2 Government documents.

2.2.1 <u>Specifications and Standards</u>. The following specifications and standards form a part of this specification to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

DEPARTMENT OF DEFENSE SPECIFICATION

MIL-PRF-38535 - Integrated Circuits (Microcircuits) Manufacturing, General Specification for.

DEPARTMENT OF DEFENSE STANDARDS

MIL-STD-883	-	Test Method Standard Microcircuits.
MIL-STD-1835	-	Interface Standard Electronic Component Case Outlines.

(Copies of these documents are available online at <u>http://assist.daps.dla.mil/quicksearch</u> or <u>http://assist.daps.dla.mil</u> from the Standardization Document Order Desk, 700 Robbins Avenue, Building 4D, Philadelphia, PA 19111-5094.)

2.3 <u>Non-Government publications</u>. The following document(s) form a part of this document to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

ELECTRONIC INDUSTRIES ALLIANCE (EIA)

EIA/JEDEC Standard No. 78 - IC Latch-Up Test

JEDEC Standard No. 20 - Standard for Description of 54/74ACXXXXX and 54/74ACTXXXXX Advanced High-Speed CMOS Devices

(Copies of these documents are available on line at <u>http://www.jedec.org</u> or from Electronic Industries Alliance, 2500 Wilson Boulevard, Arlington, VA 22201-3834).

2.4 <u>Order of precedence</u>. In the event of a conflict between the text of this document and the references cited herein, the text of this document takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.

3. REQUIREMENTS

3.1 <u>Qualification</u>. Microcircuits furnished under this specification shall be products that are manufactured by a manufacturer authorized by the qualifying activity for listing on the applicable qualified manufacturers list before contract award (see 4.3 and 6.4).

3.2 <u>Item requirements</u>. The individual item requirements shall be in accordance with MIL-PRF-38535 and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not affect the form, fit, or function as described herein.

3.3 <u>Design, construction, and physical dimensions</u>. The design, construction, and physical dimensions shall be as specified in MIL-PRF-38535 and herein.

3.3.1 Terminal connections. The terminal connections shall be as specified on figure 1.

3.3.2 <u>Truth tables</u>. The truth tables shall be as specified on figure 2.

3.3.3 <u>Switching waveforms and test circuit</u>. The switching waveforms and test circuit shall be as specified on figure 3.

3.3.4 <u>Schematic circuits</u>. The schematic circuits shall be maintained by the manufacturer and made available to the qualifying activity or preparing activity upon request.

3.3.5 <u>Case outlines.</u> The case outlines shall be as specified in 1.2.3 herein.

3.4 Lead material and finish. The lead material and finish shall be in accordance with MIL-PRF-38535 (see 6.6).

3.5 <u>Electrical performance characteristics and post irradiation end-point electrical parameter limits.</u> Unless otherwise specified, the electrical performance characteristics and postirradiation end-point electrical parameter limits are as specified in table I and apply over the case operating temperature range specified. Test conditions for these specified characteristics and limits are as specified in table I.

3.6 <u>Electrical test requirements</u>. The electrical test requirements for each device class shall be the subgroups specified in table II. The electrical tests for each subgroup are described in table I. Radiation hardness assurance level M, D, P, L, and R (see MIL-PRF-38535) in table I are postirradiation end-point electrical parameters.

3.7 Marking. Marking shall be in accordance with MIL-PRF-38535.

3.7.1 <u>Radiation hardness assurance identifier</u>. The radiation hardness assurance identifier shall be in accordance with MIL-PRF-38535 and herein (see 3.6).

3.8 <u>Microcircuit group assignment</u>. The devices covered by this specification shall be in microcircuit group number 39 (see MIL-PRF-38535, appendix A).

Test and MIL-STD-883 test method	Symbol	$\begin{array}{c} \mbox{Test conditions } \underline{1}/ \\ -55^\circ C \leq T_C \leq +125^\circ C \\ +3.0 \ V \leq V_{CC} \leq +5.5 \ V \\ \mbox{unless otherwise specified} \end{array}$		Device type <u>2</u> /	Vcc	Group A subgroups	Limi Min	ts <u>1</u> / Max	Unit
High level output voltage 3006	V _{OH1} <u>3</u> /	YOH1 3/For all inputs affecting output under test, $V_{IN} = V_{IH}$ or V_{IL} $V_{IH} = 2.10 V$ $V_{IL} = 0.90 V$ For all other inputs, $V_{IN} = V_{CC}$ or GND $I_{OH} = -50 \ \mu A$ YOH2 3/For all inputs affecting output under test, $V_{IN} = V_{IH}$ or V_{IL} $V_{IH} = 3.15 V$ $V_{IL} = 1.35 V$ For all other inputs, $V_{IN} = V_{CC}$ or GND $I_{OH} = -50 \ \mu A$ YOH2 3/For all inputs affecting output under test, $V_{IN} = V_{IH}$ or V_{IL} $V_{IL} = 1.35 V$ For all other inputs, $V_{IN} = V_{CC}$ or GND $I_{OH} = -50 \ \mu A$ YOH3For all inputs affecting output		All	3.0 V	1, 2, 3	2.9		V
	V _{OH2} <u>3</u> /			All	4.5 V	1, 2, 3	4.4		
	V _{OH3} <u>4</u> / <u>5</u> /			All	5.5 V	1, 2, 3	5.4		
		For all other inputs,	М	02, 03		1	5.4		
		V _{IN} = V _{CC} or GND I _{OH} = -50 μA	D				5.4		
			P, L, R				5.4		
<u>3</u> /		For all inputs affecting o under test, $V_{IN} = V_{IH}$ or $V_{IH} = 2.10 V$ $V_{IL} = 0.90 V$ For all other inputs, $V_{IN} = V_{CC}$ or GND $I_{OH} = -4.0 \text{ mA}$		All	3.0 V	1, 2, 3	2.4		
	V _{OH5} Fo <u>4/5/</u> V VOH5 Fo	For all inputs affecting o under test, $V_{IN} = V_{IH}$ or $V_{IH} = 3.15 V$ $V_{IL} = 1.35 V$		All	4.5 V	1, 2, 3	3.7		
		For all other inputs,	М	02, 03		1	3.7		
		$V_{IN} = V_{CC} \text{ or GND}$ $I_{OH} = -24 \text{ mA}$	D				3.7		
			P, L, R				3.7		
	V _{ОН6} <u>3</u> /	For all inputs affecting o under test, $V_{IN} = V_{IH}$ or $V_{IH} = 3.85 V$ $V_{IL} = 1.65 V$ For all other inputs, $V_{IN} = V_{CC}$ or GND $I_{OH} = -24 \text{ mA}$		All	5.5 V	1, 2, 3	4.7		V

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Test and MIL-STD-883 test method	Symbol	Test conditions $\underline{1}/$ -55°C \leq T _C \leq +125°C +3.0 V \leq V _{CC} \leq +5.5 V unless otherwise specified		Device type <u>2</u> /	V _{cc}	Group A subgroups		ts <u>1</u> /	Unit
High level output voltage 3006	V _{OH7} <u>4/ 5/ 6</u> /	For all inputs affectin under test, $V_{IN} = V_{IH}$ $V_{IH} = 3.85 V$ $V_{IL} = 1.65 V$	g output	All	5.5 V	1, 2, 3	Min 3.85	Max	V
		For all other inputs,	М	02, 03		1	3.85		
		V _{IN} = V _{CC} or GND I _{OH} = -50 mA	D				3.85		
		10H00 MA	P, L, R				3.85		
Low level output voltage 3007	V _{OL1} <u>3</u> /	For all inputs affecting output under test, $V_{IN} = V_{IH}$ or V_{IL} $V_{IH} = 2.10 V$ $V_{IL} = 0.90 V$ For all other inputs, $V_{IN} = V_{CC}$ or GND $I_{OL} = 50 \mu A$		All	3.0 V	1, 2, 3		0.1	V
	$\begin{array}{c c} V_{OL2} & \mbox{For all inputs affecting output} & \mbox{All} & \mbox{4.5 V} \\ \underline{3} / & \mbox{under test, } V_{IN} = V_{IH} \mbox{ or } V_{IL} \\ V_{IH} = 3.15 \ V \\ V_{IL} = 1.35 \ V \\ For all other inputs, \\ V_{IN} = V_{CC} \ or \ GND \\ I_{OL} = 50 \ \mu A \end{array} \qquad \qquad$	g output or V _{IL}	All	4.5 V	1, 2, 3		0.1		
		5.5 V	1, 2, 3		0.1				
		For all other inputs,	М	02, 03		1		0.1	
		$V_{IN} = V_{CC} \text{ or GND}$ $I_{OL} = 50 \ \mu \text{A}$	D					0.1	
		10Ε - 30 μΑ	P, L, R					0.1	
	$\underbrace{3}_{III} \begin{array}{l} \text{under test, } V_{IN} = V_{IH} \text{ or } V_{IL} \\ V_{IH} = 2.10 \text{ V} \\ V_{IL} = 0.90 \text{ V} \\ \text{For all other inputs,} \\ V_{IN} = V_{CC} \text{ or } \text{GND} \end{array}$	3.0 V	1, 3		0.4				
		$V_{IH} = 2.10 V$ $V_{IL} = 0.90 V$ For all other inputs,				2		0.5	
	V _{OL5}	For all inputs affectin	a output	All	4.5 V	1, 3		0.4	V
	<u>4</u> / <u>5</u> /	under test, $V_{IN} = V_{IH}$ $V_{IH} = 3.15 V$ $V_{IL} = 1.35 V$			4.0 V	2		0.5	
		For all other inputs,	М	02, 03	1	1		0.4	
		$V_{IN} = V_{CC}$ or GND	D					0.4	
		I _{OL} = 24 mA	P, L, R					0.4	

TABLE I. Electrical performance charac	cteristics - Continued.
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Test and MIL-STD-883	Symbol	$\begin{array}{c c} \mbox{Test conditions } \underline{1}/\\ -55^\circ C \leq T_C \leq +125^\circ C \end{array}$		Device type <u>2</u> /	V _{CC}	Group A subgroups	Limi	ts <u>1</u> /	Unit
test method		$+3.0 V \le V_{CC} \le +$ unless otherwise s					Min	Max	
Low level output voltage 3007	V _{OL6} <u>3</u> /	For all inputs affecting under test, $V_{IN} = V_{IH}$ $V_{IH} = 3.85 V$		All	5.5 V	1, 3		0.4	V
		$V_{IL} = 1.65 V$ For all other inputs, $V_{IN} = V_{CC}$ or GND $I_{OL} = 24 \text{ mA}$				2		0.5	
	V _{OL7} <u>4/ 5/ 6</u> /	For all inputs affecting under test, $V_{IN} = V_{IH}$ $V_{IH} = 3.85 V$ $V_{IL} = 1.65 V$		All	5.5 V	1, 2, 3		1.65	
		For all other inputs,	М	02, 03		1		1.65	
		$V_{IN} = V_{CC} \text{ or GND}$ $I_{OL} = 50 \text{ mA}$	D P, L, R					1.65 1.65	-
Positive input	V _{IC+}	For input under test,	Р, L, К	All		1	0.4	1.65	V
clamp voltage	<u>4</u> / <u>5</u> /	$I_{\rm IN} = 1 \rm{mA}$		7.01	GND	·	0.1	1.0	v
3022			М	02, 03		1	0.4	1.5	
			D				0.4	1.5	
Negativo input	V _{IC-}	For input under test,	P, L, R	A 11	-	1	0.4 -0.4	1.5 -1.5	V
Negative input clamp voltage	<u>4/</u> <u>5</u> /	$I_{\rm IN}$ = -1 mA		All	Open		-0.4	-1.5	v
3022			M	02, 03		1	-0.4	-1.5	-
			D P, L, R				-0.4 -0.4	-1.5 -1.5	-
Input current	I _{IH}	For input under test,	Ρ, L, K	All	5.5 V	1	-0.4	0.1	μA
high	<u>4</u> / <u>5</u> /	$V_{IN} = V_{CC}$		7	5.5 V	2		1.0	ματ
3010		For all other inputs, V _{IN} = V _{CC} or GND	М	02, 03		1		0.1	
			D	02,00				0.1	-
			P, L, R					0.1	
Input current		For input under test,		All	5.5 V	1		-0.1	μΑ
low 3009	<u>4</u> / <u>5</u> /	V _{IN} = GND For all other inputs,				2		-1.0	
3009		$V_{IN} = V_{CC}$ or GND	М	02, 03		1		-0.1	
			D	,				-0.1	
			P, L, R					-0.1	
Power dissipation capacitance	С _{РD} <u>7</u> /	See 4.4.1c T _C = +25°C		All	5.0 V	4		70	pF
Input capacitance 3012	C _{IN}	See 4.4.1c T _C = +25°C		All	GND	4		10	pF

TABLE I. Electrical performance characteristics - Co	ontinued.
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Test and	Symbol	Test conditions	<u>1</u> /	Device	V _{CC}	Group A	Lim	its <u>1</u> /	Unit
MIL-STD-883		$-55^{\circ}C \leq T_C \leq +125^{\circ}C$		type <u>2</u> /		subgroups	Min	Max	
test method		$3.0~V \leq V_{CC} \leq 5.5~V$							
Ouiocoat	1	unless otherwise spe For all inputs	ecified	All	5.5 V	1		2.0	^
Quiescent supply	I _{CCH}	$V_{IN} = V_{CC} \text{ or } 0.0 \text{ V}$		All	5.5 V	1 2		40.0	μA
current	<u>4</u> / <u>5</u> /		М	02, 03	-	1		15	
output high			D	02	-	•		100	
3005				03	_			75	
			P, L, R	02				1700	
				03				700	
Quiescent	I _{CCL}	For all inputs		All	5.5 V	1		2.0	μA
supply current	A/ E/	$V_{IN} = V_{CC} \text{ or } 0.0 \text{ V}$		00.00	-	2		40.0	
output low	<u>4/</u> 5/		M D	02, 03	_	1		15 100	
3005			D	02	-			75	
			P, L, R	03	-			1700	
			· , <u>-</u> , . (03	-			700	
Latch-up	Icc	t _w ≥ 100 μs		All	5.5 V	2		200	mA
input/output	(O/V1)	$t_{cool} \ge t_w$							
over-voltage	<u>8</u> /	5 μ s \leq t _r \leq 5 ms							
		$5 \ \mu s \le t_f \le 5 \ ms$							
		$V_{\text{test}} = 6.0 \text{ V}$							
		$V_{CCQ} = 5.5 V$							
Latch-up	Icc	$V_{over} = 10.5 V$ $t_w \ge 100 \ \mu s$		All	5.5 V	2		200	mA
input/output	(O/I1+)	$t_{cool} \ge t_w$		7 41	0.0 V	-		200	110 \
positive	` <u>8</u> / ´	5 μ s \leq t _r \leq 5 ms							
over-current		5 μ s \leq t _f \leq 5 ms							
		$V_{\text{test}} = 6.0 \text{ V}$							
		$V_{CCQ} = 5.5 V$							
		I _{trigger} = +120 mA		A 11	5 5 1 (000	
Latch-up		$t_w \ge 100 \ \mu s$		All	5.5 V	2		200	mA
input/output negative	(O/I1-) <u>8</u> /	$t_{cool} \ge t_w$							
over-current	<u>o</u> /	5 μ s \leq t _r \leq 5 ms 5 μ s \leq t _f \leq 5 ms							
		$V_{\text{test}} = 6.0 \text{ V}$							
		$V_{CCQ} = 5.5 V$							
		$I_{trigger} = -120 \text{ mA}$							
Latch-up	I _{CC}	t _w ≥ 100 μs		All	5.5 V	2		100	mA
supply	(O/V2)	$t_{cool} \ge t_w$							
over-voltage	<u>8</u> /	$5 \ \mu s \leq t_r \leq 5 \ ms$							
		$5 \ \mu s \le t_f \le 5 \ ms$							
		$V_{\text{test}} = 6.0 \text{ V}$							
		$V_{CCQ} = 5.5 V$							
		V _{over} = 9.0 V		l			I	l	

TABLE I.	Electrical	performance	characteristics -	Continued.
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ML_STD-883 test method -55° C ≤ T_C ≤ 125° C 3.0 V ≤ V_C ≤ 55 V type 2/ 3.0 V ≤ V_C ≤ 55 V subgroups Min Max N vint table test output voltage 3014 4/ 5/ 9/ V _H = 2.50 V V _H = 2.50 V M 02,03 3.0 V 7 L H Vint able verify output Vo verify output Vo verify output Vo P, L, R 02 3.0 V 7, B L H Propagation delay time, An to On 3003 thut, n C = 50 pF R = 500Ω see figure 3 02 3.0 V 9, 11 1.0 13.0 10 10 10.0 10.5 9 10 10 11.5 10 13.0 10 10 11.5 10 10 10.1 11.5 10 10 10 10.5 10 10 10 10.5 10 10 10 10.5 10	Test and	Symbol	Test conditions	1/	Device	V _{CC}	Group A	Lim	its 1/	Unit
test method 3.0 V X Co < 5.5 V N L N L N L H Truth table test output voltage 4/ 5/ 9/ Vm = 0.45 V Vm = 2.50 V M 02,03 3.0 V 7 L H 3014 Vm = 0.45 V D D 0 0 0.0 V L H 3014 Vm = 0.65 V D D 0		0,11201								•••••
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Propagation delay time, An to On 3003 thet,t, thurt, 4 / 5/ 10 / 11/ CL = 50 pF (s = 50 Q) (s = 6 gure 3) 02 (s = 6 gure 3) 30.V 9, 11 1.0 11.5 (s = 0 q) (s = 0 q) ns M 02 (s = 0 q) 03 (s = 6 gure 3) M 02 (s = 0 q) 30.V 9, 11 1.0 11.5 (s = 0 q) 1.0 10.0 1.0										
$ \begin{array}{c c c c c c c c c c c c c c c c c c c $	Propagation	tour 4	$C_{\rm L} = 50 \text{ pc}$		02	30V	Q 11	10	13.0	ns
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$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$						4 5 \/	0 11			
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$					02	4.5 V				ns
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$					00	4				
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$			see ligure 5		03					
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$						-				
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$				M		-	9			
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$										
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$				D						
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$										
$ \begin{array}{c c c c c c c c c c c c c c c c c c c $				P, L, R						
$ \begin{array}{c c c c c c c c c c c c c c c c c c c $										
$ \begin{array}{c c c c c c c c c c c c c c c c c c c $					02	3.0 V				ns
$\begin{array}{c c c c c c c c c c c c c c c c c c c $	delay time,	t _{PLH2}								
$\begin{array}{c c c c c c c c c c c c c c c c c c c $			see figure 3		03					
$\begin{array}{c c c c c c c c c c c c c c c c c c c $										
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$	3003	<u>10/ 11</u> /		М			9			
$ \begin{array}{ c c c c c c c c c c c c c c c c c c c$										
$\begin{array}{ c c c c c c c c c c c c c c c c c c c$				D						
$ \begin{array}{c c c c c c c c c c c c c c c c c c c $										
$\begin{array}{c c} C_L = 50 \ pF \\ R_L = 500\Omega \\ see \ figure \ 3 \end{array} \qquad \begin{array}{c c} 02 \\ R_L = 500\Omega \\ see \ figure \ 3 \end{array} \qquad \begin{array}{c c} 02 \\ 03 \\ \hline \\ 0 \\ 0 \\ \hline \\ 0 \\ 0 \\ \hline \\ 0 \\ 0 \\ \hline \\ 0 \\ 0$				P, L, R				1.0		
$ \begin{array}{c ccccccccccccccccccccccccccccccccccc$					03					
$ \begin{array}{c c c c c c c c c c c c c c c c c c c $			C _L = 50 pF		02	4.5 V	9, 11	1.0	11.5	ns
M 02 10 1.0 11.0 03 03 1.0 11.5 1.0 8.5 D 02 1.0 11.5 1.0 8.5 P, L, R 02 1.0 11.5 1.0 8.5			$R_L = 500\Omega$				10	1.0		
M 02 10 1.0 11.0 M 02 9 1.0 11.5 03 1.0 8.5 D 02 1.0 11.5 03 1.0 8.5 P, L, R 02 1.0 11.5			see figure 3		03] [1.0	8.5	
03 1.0 8.5 D 02 1.0 11.5 03 1.0 8.5 P, L, R 02 1.0 11.5								1.0	11.0	
03 1.0 8.5 D 02 1.0 11.5 03 1.0 8.5 P, L, R 02 1.0 11.5				М	02] [
D 02 1.0 11.5 03 1.0 8.5 P, L, R 02 1.0 11.5						1				
03 1.0 8.5 P, L, R 02 1.0 11.5				D		1				1
P, L, R 02 1.0 11.5						1				
				P, L, R		1				
03 1.0 8.5					03	1			8.5	

TABLE I. <u>Electrical performance characteristics</u> – Continued.

Test and	Symbol	Test conditions 1	/	Device	V _{CC}	Group A	Lim	its <u>1</u> /	Unit
MIL-STD-883	-	-55°C ≤ T _C ≤ +125	°C	type <u>2</u> /		subgroups	Min	Max	
test method		$3.0~V \le V_{CC} \le 5.5$	V						
		unless otherwise spe	cified						
Propagation	t _{PHL3} ,	C _L = 50 pF		02	3.0 V	9, 11	1.0	15.5	ns
delay time,	t _{PLH3}	R _L = 500Ω				10	1.0	17.0	
E3 to On		see figure 3	М	02		9	1.0	15.5	
3003	<u>4</u> / <u>5</u> /		D	02			1.0	15.5	
	<u>10/11</u> /		P, L, R	02			1.0	15.5	
		C _L = 50 pF		02	4.5 V	9, 11	1.0	11.5	ns
		R _L = 500Ω				10	1.0	13.5	
		see figure 3	М	02		9	1.0	11.5	
			D	02			1.0	11.5	
			P, L, R	02			1.0	11.5	

TABLE I. <u>Electrical performance characteristics</u> – Continued.

- 1/ Each input/output, as applicable, shall be tested at the specified temperature for the specified limits. Output terminals not designated shall be high level logic, low level logic, or open, except as follows:
 - a. V_{IC} (pos) tests, the GND terminal can be open. $T_C = +25^{\circ}C$.
 - b. V_{IC} (neg) tests, the V_{CC} terminal shall be open. T_C = +25°C.
 - c. All I_{CC} tests, the output terminal shall be open. When performing these tests, the current meter shall be placed in the circuit such that all current flows through the meter.

For negative and positive voltage and current values, the sign designates the potential difference in reference to GND and the direction of current flow, respectively; and the absolute value of the magnitude, not the sign, is relative to the minimum and maximum limits, as applicable, listed herein.

- 2/ The word "All" in the device type column means non-RHA limits for all devices types. M, D, P, L, and R in the conditions column specify the postirradiation limits for those device types specified in the device type column.
- 3/ This test is guaranteed, if not tested, to the limits specified in table I.
- 4/ RHA samples do not have to be tested at -55°C and +125°C prior to irradiation.
- 5/ When performing postirradiation electrical measurements for any RHA level, $T_A = +25^{\circ}C$. Limits shown are guaranteed at $T_A = +25^{\circ}C \pm 5^{\circ}C$.
- <u>6</u>/ Transmission driving tests are performed at V_{CC} = 5.5 V dc with a 2 ms duration maximum.
- $\underline{7}$ / Power dissipation capacitance (C_{PD}) determines the no load dynamic power consumption, $P_D = (C_{PD} + C_L) (V_{CC} \times V_{CC}) f + (I_{CC} \times V_{CC})$ and the dynamic current consumption, $I_S = (C_{PD} + C_L)V_{CC}f + I_{CC}$. For both C_{PD} and I_S , f is the frequency of the input signal.
- 8/ See EIA/JEDEC STD. No. 78 for electrically induced latch-up test methods and procedures. The values listed for I_{trigger} and V_{over} are to be accurate within ±5 percent.
- <u>9</u>/ Tests shall be performed in sequence, attributes data only. Functional tests shall include the truth tables and other logic patterns used for fault detection. Functional tests shall be performed in sequence as approved by the qualifying activity on qualified devices. $H \ge 2.5 \text{ V}$, L < 2.5 V; high inputs = 3.7 V and low inputs = 0.6 V for V_{CC} = 4.5 V and $H \ge 1.5 \text{ V}$, L < 1.5 V; high inputs = 2.5 V and low inputs = 0.45 V for V_{CC} = 3.0 V. Tests at V_{CC} = 3.0 V are for RHA specified devices only (T_A = +25°C ±5°C). Functional tests at V_{CC} = 3.0 V are worst case for RHA specified devices.
- <u>10</u>/ Devices are tested at V_{CC} = 3.0 V and V_{CC} = 4.5 V at T_C = +125°C for sample testing and at V_{CC} = 3.0 V and V_{CC} = 4.5 V at T_C = +25°C for screening. Other voltages of V_{CC} and temperatures are guaranteed, if not tested. See 4.4.1d.
- <u>11</u>/ AC limits at V_{CC} = 5.5 V are equal to the limits at V_{CC} = 4.5 V and guaranteed by testing at V_{CC} = 4.5 V. Minimum ac limits for V_{CC} = 5.5 V are 1.0 ns and guaranteed by guardbanding the V_{CC} = 4.5 V minimum limits to 1.5 ns. For propagation delay tests, all paths must be tested.

Device types	()2	0	3
Case outlines	E, F, Z	2	E, F, Z	2
Terminal number		Termina	al symbol	
1	A0	NC	ĒA	NC
2	A1	A0	A0A	ĒA
3	A2	A1	A1A	A0A
4	Ē1	A2	Ō0A	A1A
5	E2	Ē1	01A	0 0A
6	E3	NC	02A	NC
7	07	Ē2	0 3A	01A
8	GND	E3	GND	02A
9	<u> </u>	07	0 3B	0 3A
10	<u>0</u> 5	GND	O2B	GND
11	<u>0</u> 4	NC	01B	NC
12	O 3	<u> </u>	<u>О</u> 0В	<u>О</u> зв
13	<u>0</u> 2	<u>0</u> 5	A1B	O2B
14	01	<u>0</u> 4	A0B	01B
15	00	O 3	ĒB	<u>О</u> 0В
16	V _{CC}	NC	V _{CC}	NC
17		<u>0</u> 2		A1B
18		01		A0B
19		00		EB
20		V _{CC}		V _{CC}

NC = No connection

FIGURE 1. Terminal connections.

Device type 02

		Inp	uts						Out	puts			
Ē1	Ē2	E3	A0	A1	A2	Ō0	01	02	<u>0</u> 3	Ō4	<u>0</u> 5	<u> </u>	07
Н	Х	Х	Х	Х	Х	Н	Н	Н	Н	Н	Н	Н	Н
Х	Н	Х	Х	Х	Х	Н	Н	Н	Н	Н	Н	Н	Н
Х	Х	L	Х	Х	Х	Н	Н	Н	Н	Н	Н	Н	Н
L	L	Н	L	L	L	L	Н	Н	Н	Н	Н	Н	Н
L	L	Н	Н	L	L	Н	L	Н	Н	Н	Н	Н	Н
L	L	Н	L	Н	L	Н	Н	L	Н	Н	Н	Н	Н
L	L	Н	Н	Н	L	Н	Н	Н	L	Н	Н	Н	Н
L	L	Н	L	L	Н	Н	Н	Н	Н	L	Н	Н	Н
L	L	Н	Н	L	Н	Н	Н	Н	Н	Н	L	Н	Н
L	L	Н	L	Н	Н	Н	Н	Н	Н	Н	Н	L	Н
L	L	Н	Н	Н	Н	Н	Н	Н	Н	Н	Н	Н	L

Device type 03

	Inputs			Out	puts	
Ē	A0	A1	00	01	02	Ō3
Н	Х	Х	Н	Н	Н	Н
L	L	L	L	Н	Н	Н
L	Н	L	Н	L	Н	Н
L	L	Н	Н	Н	L	Н
L	Н	Н	Н	Н	Н	L

H = High voltage level L = Low voltage level X = Irrelevant

FIGURE 2. Truth tables.

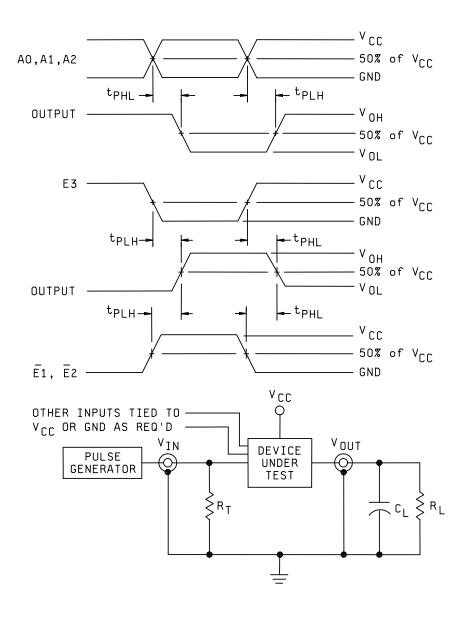
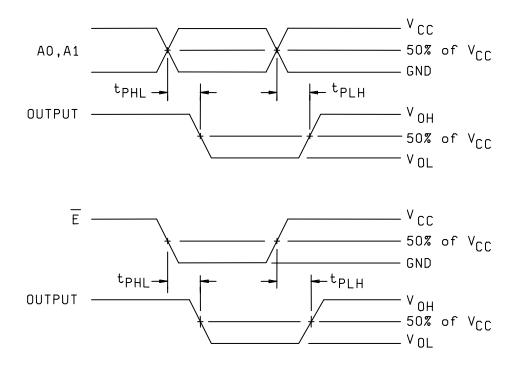


FIGURE 3. Switching waveforms and test circuit.



NOTES:

- 1. $C_L = 50 pF$ or equivalent (includes test jig and probe capacitance).
- 2. $R_L = 500\Omega$ or equivalent.
- 3. $R_T = 50\Omega$ or equivalent.
- 4. Input signal from pulse generator: V_{IN} = 0.0 V to V_{CC} ; PRR \leq 10 MHz; duty cycle = 50 percent, $t_r \leq$ 3.0 ns; $t_f \leq$ 3.0 ns; t_r and t_f shall be measured from 10% of V_{CC} to 90% of V_{CC} and from 90% of V_{CC} to 10% of V_{CC} , respectively.
- 5. Timing parameters shall be tested at a minimum input frequency of 1 MHz.

FIGURE 3. Switching waveforms and test circuit - Continued.

4. VERIFICATION

4.1 <u>Sampling and inspection</u>. Sampling and inspection procedures shall be in accordance with MIL-PRF-38535 or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not affect the form, fit, or function as described herein.

4.1.1 <u>Burn-in and life test circuits</u>. Burn-in and life test circuits shall be constructed so that the devices are stressed at the maximum operating conditions stated in 4.2c or 4.2d, as applicable, or equivalent as approved by the qualifying activity.

4.2 <u>Screening</u>. Screening shall be in accordance with MIL-PRF-38535 and shall be conducted on all devices prior to qualification and conformance inspection. The following additional criteria shall apply:

- a. The burn-in test duration, test condition, and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The burn-in test circuit shall be maintained under document control by the device manufacturer's Technology Review Board (TRB) in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015 of MIL-STD-883.
- b. Delete the sequence specified as interim (pre-burn-in) electrical parameters through interim (post-burn-in) electrical parameters of table IA of MIL-PRF-38535 and substitute lines 1 through 7 of table II herein.
- c. Unless otherwise specified in the manufacturer's QM plan for static burn-in, test condition A, method 1015 of MIL-STD-883, the test duration for each static test shall be 24 hours minimum for class S devices and in accordance with table I of method 1015 for class B devices.
 - (1) For static burn-in I, all inputs shall be connected to GND. Outputs may be open or connected to $V_{CC}/2 \pm 0.5 \text{ V}$. Resistors R1 are optional on both inputs and open outputs, and required on outputs connected to $V_{CC}/2 \pm 0.5 \text{ V}$. R1 = 220 Ω to 47 k Ω .
 - (2) For static burn-in II, all inputs shall be connected through the R1 resistors to V_{CC}. Outputs may be open or connected to V_{CC}/2 ±0.5 V. Resistors are optional on open outputs, and required on outputs connected to V_{CC}/2 ±0.5 V. R1 = 220Ω to 47 kΩ.
 - (3) $V_{CC} = 5.5 \text{ V} + 0.5 \text{ V}, -0.00 \text{ V}.$
- d. Unless otherwise specified in the manufacturer's QM plan for dynamic burn-in, test condition D, method 1015 of MIL-STD-883, the following shall apply:
 - (1) Input resistors = 220Ω to 2 k $\Omega \pm 20$ percent.
 - (2) Output resistors = $220\Omega \pm 20$ percent.
 - (3) $V_{CC} = 5.5 \text{ V} + 0.5 \text{ V}, -0.00 \text{ V}.$
 - (4) All control inputs shall be connected through a resistor in parallel to V_{CC} or GND, as applicable, enabling the function of the control input. Each output shall be connected through a resistor to V_{CC}/2 ±0.5 V. For device type 02, input A0 shall be connected through a resistor to a clock pulse (CP0); input A1 shall be connected through a resistor to a clock pulse (CP0); input A1 shall be connected through a resistor to a clock pulse (CP2). For device type 03, inputs A0A and A0B shall each be connected through a resistor to a common clock pulse (CP0); and inputs A1A and A1B shall each be connected through a resistor to a common clock pulse (CP1).
 - (5) CP0, CP1, and CP2 = 25 kHz to 1 MHz square waves; $f_{CP1} = f_{CP0}/2$; $f_{CP2} = f_{CP0}/4$; duty cycle = 50 percent ±15 percent; V_{IH} = 4.5 V to V_{CC} ; V_{IL} = 0 V ±0.5 V; t_r , $t_f \le 100$ ns.
- e. Interim and final electrical test parameters shall be as specified in table II.
- f. For class S devices, post dynamic burn-in, or class B devices, post static burn-in, electrical parameter measurements may, at the manufacturer's option, be performed separately or included in the final electrical parameter requirements.

4.2.1 Percent defective allowable (PDA).

- a. The PDA for class S devices shall be 5 percent for static burn-in and 5 percent for dynamic burn-in, based on the exact number of devices submitted to each separate burn-in.
- b. Static burn-in I and II failures shall be cumulative for determining the PDA.
- c. The PDA for class B devices shall be in accordance with MIL-PRF-38535 for static burn-in. Dynamic burn-in is not required.
- d. Those devices whose measured characteristics, after burn-in, exceed the specified delta (Δ) limits or electrical parameter limits specified in table I, subgroup 1, are defective and shall be removed from the lot. The verified number of failed devices times 100 divided by the total number of devices in the lot initially submitted to burn-in shall be used to determine the percent defective for the lot and the lot shall be accepted or rejected based on the specified PDA.
- 4.3 Qualification inspection. Qualification inspection shall be in accordance with MIL-PRF-38535.

4.4 <u>Technology Conformance inspection (TCI)</u>. Technology conformance inspection shall be in accordance with MIL-PRF-38535 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.5).

- 4.4.1 Group A inspection. Group A inspection shall be in accordance with table III of MIL-PRF-38535 and as follows:
 - a. Tests shall be performed in accordance with table II herein.
 - b. O/V and O/I (latch-up) tests shall be measured only for initial qualification and after process or design changes which may affect the performance of the device. Latch-up test shall be considered destructive. Test all applicable pins on 5 devices with no failures.
 - c. C_{IN} and C_{PD} shall be measured only for initial qualification and after process or design changes that may affect capacitance. C_{IN} shall be measured between the designated terminal and GND at a frequency of 1 MHz. C_{PD} shall be tested in accordance with the latest revision of JEDEC Standard No. 20 and table I herein. For C_{IN} and C_{PD}, test all applicable pins on five devices with zero failures.
 - d. Subgroups 9 and 11 shall be measured only for initial qualification and after process or design changes which may affect dynamic performance.
 - e. Subgroups 7 and 8 tests shall be sufficient to verify the truth table.

4.4.2 Group B inspection. Group B inspection shall be in accordance with table II of MIL-PRF-38535.

4.4.3 Group C inspection. Group C inspection shall be in accordance with table IV of MIL-PRF-38535 and as follows:

- a. End-point electrical parameters shall be as specified in table II herein. Delta limits shall apply only to subgroup 1 of group C inspection and shall consist of tests specified in table III herein.
- b. The steady-state life test duration, test condition, and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The burn-in test circuit shall be maintained under document control by the device manufacturer's Technology Review Board (TRB) in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005 of MIL-STD-883.

Line	MIL-PRF-38535		Class S device	e 1/	(Class B device	. 1/
no.	test requirements	Reference	Table I	Table III	Reference	Table I	Table III
110.	lest requirements	paragraph	subgroups	delta limits	paragraph	subgroups	delta
			<u>2</u> /	<u>3</u> /		<u>2</u> /	limits <u>3</u> /
1	Interim electrical		1			1	
	parameters						
2	Static burn-in I	4.2c	Req'd			Not req'd	
	(method 1015)	4.5.2	<u>4/</u> 1				
3	Same as line 1			Δ		— • • •	
4	Static burn-in II	4.2c	Req'd		4.2c	Req'd	
	(method 1015)	4.5.2	<u>4</u> /		4.5.2	<u>5</u> /	
5	Same as line 1	4.2e	1*	Δ	4.2e	1*	Δ
6	Dynamic burn-in	4.2d	Req'd			Not req'd	
	(method 1015)	4.5.2	<u>4</u> /				
7	Same as line 1	4.2e	1	Δ			
8	Final electrical		1*, 2, 7*, 9			1*, 2, 7, 9	
	parameters					<u>5</u> /	
9	Group A test	4.4.1	1, 2, 3, 4, 7,		4.4.1	1, 2, 3, 4, 7,	
	requirements		8, 9, 10, 11			8, 9, 10, 11	
	(method 5005)						
10	Group B test	4.4.2	1, 2, 3, 7, 8,	Δ			
	when using the		9, 10, 11				
	method 5005						
44	QCI option				4.4.3	1.0	
11	Group C end-				4.4.3	1, 2	Δ
	point electrical parameters						
	(method 5005)						
12	Group D end-	4.4.4	1, 2, 3		4.4.4	1, 2	
12	point electrical	7.7.7	1, 2, 0		7.7.7	ı, <i>2</i>	
	parameters						
	(method 5005)						
13	Group E end-	4.4.5	1, 7, 9		4.4.5	1, 7, 9	
	point electrical						
	parameters						
	(method 5005)						

	TABLE II.	Burn-in and electrical test requirements.
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- 1/ Blank spaces indicate tests are not applicable.
- 2/ * indicates PDA applies to subgroups 1 and/or 7, as applicable (see 4.2.1).
- $\underline{3}$ \triangle indicates delta limits and shall be required only on table I, subgroup 1, where specified, and the delta values shall be computed with reference to the previous interim electrical parameters (line 1).
- 4/ On all class S lots, the device manufacturer shall maintain read-and-record data (as a minimum on disk) for burn-in electrical parameters (group A, subgroup 1), in accordance with method 5004 of MIL-STD-883. For preburn-in and interim electrical parameters, the read-and-record requirements are for delta measurements only.
- 5/ The device manufacturer may, at his option, either complete subgroup 1 electrical parameter measurements, including delta measurements, within 96 hours after burn-in completion (removal of bias) or may complete subgroup 1 electrical measurements without delta measurements within 24 hours after burn-in completion (removal of bias). When the manufacturer elects to perform the subgroup 1 electrical parameter measurements without delta measurements, there is no requirement to perform the pre-burn-in electrical tests (first interim electrical parameters test in table II).

Parameter <u>1</u> /	Device types	Limits
I _{CCH} , I _{CCL}	All	±100 nA

TABLE III.	Delta limits at 25°C.
------------	-----------------------

<u>1</u>/ The above parameters shall be recorded before and after the required burn-in and life tests to determine deltas (Δ).

4.4.4 <u>Group D inspection</u>. Group D inspection shall be in accordance with table V of MIL-PRF-38535. End-point electrical parameters shall be as specified in table II herein.

4.4.5 <u>Group E inspection</u>. Group E inspection is required only for parts intended to be marked as radiation hardness assured (see 3.7 herein). RHA levels for device classes B and S shall be as specified in MIL-PRF-38535.

- a. End-point electrical parameters shall be as specified in table II herein.
- b. For device classes B and S, subgroups 1 and 2 in table V, method 5005 of MIL-STD-883 shall be tested as appropriate for device construction.
- c. RHA tests for device classes B and S for levels M, D, P, L, and R shall be performed through each level to determine at what levels the devices meet the RHA requirements. These RHA tests shall be performed for initial qualification and after design or process changes which may affect the RHA performance of the device.
- d. Prior to irradiation, each selected sample shall be assembled in its qualified package. It shall pass the specified group A electrical parameters in table I for subgroups specified in table II herein.
- e. For device classes B and S, the devices shall be subjected to radiation hardness assurance tests as specified in MIL-PRF-38535 for the RHA level being tested. All device classes must meet the postirradiation end-point electrical parameter limits as defined in table I at T_A = +25°C ±5°C, after exposure, to the subgroups specified in table II herein.

4.4.5.1 <u>Total dose irradiation testing</u>. Total dose irradiation testing shall be performed in accordance with MIL-STD-883, method 1019, condition A, and as specified herein. Prior to and during total dose irradiation characterization and testing, the devices for characterization shall be biased so that 50 percent are at inputs high and 50 percent are at inputs low, and the devices for testing shall be biased to the worst case condition established during characterization. Devices shall be biased as follows:

- a. Input tested high, V_{CC} = 5.5 V dc +5%, R_{CC} = $10\Omega + 20\%$, V_{IN} = 5.0 V dc +5%, R_{IN} = 1 k Ω +20%, and all outputs are open.
- b. Inputs tested low, V_{CC} = 5.5 V dc +5%, R_{CC} = 10 Ω +20%, V_{IN} = 0.0 V dc, R_{IN} = 1 k Ω +20%, and all outputs are open.

4.4.5.1.1 <u>Accelerated aging test</u>. Accelerated aging shall be performed on class B and S devices requiring an RHA level greater that 5k rads (Si). The post-anneal end-point electrical parameter limits shall be as specified in table I herein and shall be the preirradiation end-point electrical parameter limit at $+25^{\circ}C \pm 5^{\circ}C$. Testing shall be performed at initial qualification and after any design or process changes which may affect the RHA response of the device.

4.5 <u>Methods of inspection</u>. Methods of inspection shall be specified and as follows:

4.5.1 <u>Voltage and current</u>. Unless otherwise specified, all voltages given are referenced to the microcircuit GND terminal. Currents given are conventional current and positive when flowing into the referenced terminal.

4.5.2 <u>Burn-in and life test cool down procedures</u>. When the burn-in and life tests are completed and prior to removal of bias voltages, the devices under test (DUT) shall be cooled to within 10°C of their power stable condition at room temperature; then, electrical parameter end-point measurements shall be performed.

4.5.3 <u>Quiescent supply current</u>. When performing quiescent supply current measurements (I_{CC}), the meter shall be placed so that all currents flow through the meter.

5. PACKAGING

5.1 <u>Packaging</u>. For acquisition purposes, the packaging requirements shall be as specified in the contract or order (see 6.2). When packaging of materiel is to be performed by DoD or in-house contractor personnel, these personnel need to contact the responsible packaging activity to ascertain packaging requirements. Packaging requirements are maintained by the Inventory Control Point's packaging activity within the Military Service or Defense Agency, or within the military service's system commands. Packaging data retrieval is available from the managing Military Department's or Defense Agency's automated packaging files, CD-ROM products, or by contacting the responsible packaging activity.

6. NOTES

(This section contains information of a general or explanatory nature that may be helpful, but is not mandatory.)

6.1 <u>Intended use.</u> Microcircuits conforming to this specification are intended for original equipment design application and logistic support of existing equipment.

- 6.2 Acquisition requirements. Acquisition documents should specify the following:
 - a. Title, number, and date of the specification.
 - b. PIN and compliance identifier, if applicable (see 1.2).
 - c. Requirements for delivery of one copy of the conformance inspection data pertinent to the device inspection lot to be supplied with each shipment by the device manufacturer, if applicable.
 - d. Requirements for certificate of compliance, if applicable.
 - e. Requirements for notification of change of product or process to contracting activity in addition to notification to the qualifying activity, if applicable.
 - f. Requirements for failure analysis (including required test condition of method 5003 of MIL-STD-883), corrective action and reporting of results, if applicable.
 - g. Requirements for product assurance and radiation hardness assurance options.
 - h. Requirements for special carriers, lead lengths, or lead forming, if applicable. These requirements should not affect the PIN. Unless otherwise specified, these requirements will not apply to direct purchase by or direct shipment to the Government.
 - i. Requirements for "JAN" marking.
 - j. Packaging requirements (see 5.1).

6.3 <u>Superseding information</u>. The requirements of MIL-M-38510 have been superseded to take advantage of the available Qualified Manufacturer Listing (QML) system provided by MIL-PRF-38535. Previous references to MIL-M-38510 in this document have been replaced by appropriate references to MIL-PRF-38535. All technical requirements now consist of this specification and MIL-PRF-38535. The MIL-M-38510 specification sheet number and PIN have been retained to avoid adversely impacting existing government logistics systems and contractors parts lists.

6.4 <u>Qualification</u>. With respect to products requiring qualification, awards will be made only for products which are, at the time of award of contract, qualified for inclusion in Qualified Manufacturers List QML-38535 whether or not such products have actually been so listed by that date. The attention of the contractors is called to these requirements, and manufacturers are urged to arrange to have the products that they propose to offer to the Federal Government tested for qualification in order that they may be eligible to be awarded contracts or purchase orders for the products covered by this specification. Information pertaining to qualification of products may be obtained from DSCC-VQ, P.O. Box 3990, Columbus, Ohio 43218-3990.

6.5 <u>Abbreviations, symbols, and definitions.</u> The abbreviations, symbols, and definitions used herein are defined in MIL-PRF-38535, MIL-HDBK-1331, and as follows:

C _{IN}	Input terminal-to-GND capacitance
GND	Ground zero voltage potential
I _{CCH}	Quiescent supply current, outputs high
	Quiescent supply current, outputs low
I _{IL}	Input current low
I _{IH}	Input current high
T _C	Case temperature
Τ _A	Ambient temperature
V _{CC}	Positive supply voltage
C _{PD}	Power dissipation capacitance
V _{IC}	Input clamp voltage
O/V	Latch-up over-voltage
O/I	Latch-up over-current
t _w	Trigger duration (width)

6.6 <u>Logistic support</u>. Lead materials and finishes (see 3.4) are interchangeable. Unless otherwise specified, microcircuits acquired for Government logistic support will be acquired to device class S for National Aeronautics and Space Administration or class B for Department of Defense (see 1.2.2), lead material and finish A (see 3.4). Longer length leads and lead forming should not affect the part number.

6.7 <u>Data reporting</u>. When specified in the purchase order or contract, a copy of the following data, as applicable, will be supplied.

- Attributes data for all screening tests (see 4.2) and variables data for all static burn-in, dynamic burn-in, RHA tests, and steady-state life tests (see 3.6).
- b. A copy of each radiograph.
- c. The technology conformance inspection (TCI) data (see 4.4).
- d. Parameter distribution data on parameters evaluated during burn-in (see 3.6).
- e. Final electrical parameters data (see 4.2e).
- f. RHA delta limits.

6.8 <u>Substitutability</u>. The cross-reference information below is presented for the convenience of users. Microcircuits covered by this specification will functionally replace the listed generic-industry type. Generic-industry microcircuit types may not have equivalent operational performance characteristics across military temperature ranges, post irradiation performance or reliability factors equivalent to MIL-M-38510 device types and may have slight physical variations in relation to case size. The presence of this information should not be deemed as permitting substitution of generic-industry types for MIL-M-38510 types or as a waiver of any of the provisions of MIL-PRF-38535.

Military device	Generic-industry
type <u>1</u> /	type
01	54AC42
02	54AC138
03	54AC139
04	54AC154

1/ Device types 01 and 04 will be included in a later revision of this specification.

6.9 <u>Changes from previous issue</u>. Marginal notations are not used in this revision to identify changes with respect to the previous issue due to the extent of the changes.

Custodians: Army - CR Navy - EC Air Force - 11 DLA - CC Preparing activity: DLA - CC

(Project 5962-2087)

Review activities: Army - MI, SM Navy - AS, CG, MC, SH, TD Air Force – 03, 19, 99

NOTE: The activities listed above were interested in this document as of the date of this document. Since organizations and responsibilities can change, you should verify the currency of the information above using ASSIST Online database at http://assist.daps.dla.mil.